

MacPherson Kwok Chen & Heid LLP

1762 Technology Drive, Suite 226

San Jose, CA 95110

Tel. (408) 392-9250

Fax (408) 392-9262

2402 Michelson Drive, Suite 210

Irvine, CA 92612

Tel. (949) 752-7040

Fax (949) 752-7049

Email: mailbox@macpherson-kwok.com



1762

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DEC 29 2003

TC 1700

December 15, 2003

Mail Stop Non-Fee AMENDMENT

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Re:	Applicant(s):	Woo Sik Yoo
	Assignee:	WaferMasters, Inc.
Title:	Method Of Forming An Oxide Layer (As Amended)	
Serial No.:	10/085,498	
Examiner:	Kirsten Jolley	Filed: February 26, 2002
Docket No.:	M-11549 US	Group Art Unit: 1762

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter; and
- (3) Response to Office Action (12 pages).



No additional fee is required.



The fee has been calculated as shown below:

CLAIMS AS AMENDED

	Claims Remaining <u>After Amendment</u>		Highest No. Previously Paid For		Present Extra	Rate	Additional Fee
Total Claims	20	Minus	31	=	0	x \$18.00	\$ 0
Independent Claims	2	Minus	5	=	0	x \$84.00	\$ 0
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application					\$	
<input type="checkbox"/>	Fee for Request for Extension of Time					\$	

Total additional fee for this Amendment:

- Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.
- Please charge our Deposit Account No. 50-2257 in the amount of \$
- Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

Total: \$0

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450, on December 15, 2003.

Sandy Kim

December 15, 2003

Respectfully submitted,

Theodore P. Lopez
Attorney for Applicants
Reg. No. 44,881



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Assignee: WaferMasters, Inc.

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Serial No.: 10/085498 Filing Date: February 26, 2002

Examiner: Jolley, Kirsten Group Art Unit: 1762

Docket No.: M-11549 US

Irvine, California
December 15, 2003

RESPONSE TO NON-FINAL OFFICE ACTION

Dear Sir:

In response to the Office Action dated September 15, 2003, Applicants submit the following amendments and remarks.